

Search Notes

Application/Control No.

10/654,168

Examiner

Ephrem Alemu

Applicant(s)/Patent under
Reexamination

DIVERGILIO ET AL.

Art Unit

2821

SEARCHED

Class	Subclass	Date	Examiner
315	506, 505, 507, 501, 500	2/28/2005	EA
250	423-427	2/28/2005	EA
250	492.2	3/1/2005	EA

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Searched EAST Search Terms: Quadrupole lens electrode ion implantation undulator voltage supply unipolar bipolar switching	2/28/2005	EA